

Notice of References Cited	Application/Control No. 10/054,551		Applicant(s)/Patent Under Reexamination DOHMEN ET AL.	
	Examiner Linda Wong		Art Unit 2611	Page 1 of 1

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*	B	US-6,735,725	05-2004	Wu et al.	714/704
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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